



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4261

SERIAL NUMBER 10/612,041	FILING DATE 07/03/2003 RULE	CLASS 438	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 2557-000153/US
-----------------------------	-----------------------------------	--------------	------------------------	--

APPLICANTS

Ja-Hum Ku, Seongnam-City, KOREA, REPUBLIC OF;

Chang-Won Lee, Seoul, KOREA, REPUBLIC OF;
 Seong-Jun Heo, Seoul, KOREA, REPUBLIC OF; Min-Chul Sun, Busan Metropolitan City, KOREA,
 REPUBLIC OF;
 Sun-Pil Youn, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA *****

None sp.

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-39834 07/09/2002

verified sp

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/07/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 69	INDEPENDENT CLAIMS 4
Verified and Acknowledged	Examiner's Signature Initials				

ADDRESS

30593
 HARNESS, DICKEY & PIERCE, P.L.C.
 P.O. BOX 8910
 RESTON , VA
 20195

TITLE

Method of fabricating a semiconductor device having a silicon oxide layer, a method of fabricating a semiconductor device having dual spacers, a method of forming a silicon oxide layer on a substrate, and a method of forming dual spacers on a conductive material layer

All Fees

FILING FEE
RECEIVED
1716

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

- 1.16 Fees (Filing)
- 1.17 Fees (Processing Ext. of time)
- 1.18 Fees (Issue)
- Other _____
- Credit